

UTILITY PATENT APPLICATION

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PATENTS AND TRADEMARKS  
Washington D.C. 20231

Docket No. 3008-34  
Client No. PHCF-01103

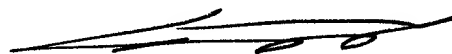
Sir:

Transmitted herewith for filing is the patent application of:  
INVENTOR(S): Fumihito Oka, Shinichi Muramatsu and Yasushi Minagawa  
FOR: CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR DEVICE,  
CRYSTALLINE SILICON THIN FILM PHOTOVOLTAIC DEVICE, AND PROCESS  
FOR PRODUCING CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR  
DEVICE

Enclosed are:

- ☒ 33 pages of specification, claims, abstract
- ☐ Declaration & Power of Attorney.
- ☐ Priority Claimed
- ☒ 3 sheets of drawing(s).
- ☐ An assignment of the invention to \_\_\_\_\_  
and the assignment recordation fee.
- ☐ Certified copy of \_\_\_\_\_
- ☐ An associate power of attorney.
- ☐ Information Disclosure Statement, Form PTO-1449 and reference.
- ☐ I hereby certify that the invention disclosed in the attached  
application has not and is not presently intended to be the  
subject of an application filed in another country, or under a  
multilateral agreement, that requires publication at eighteen  
months after filing. I hereby request that the attached  
application not be published under 35 USC § 122(b).

LALOS & KEEGAN



Alfred A. Stadnicki  
Registration No. 30,226

1146 Nineteenth Street, N.W.  
Fifth Floor  
Washington, D.C. 20036  
Telephone (202) 887-5555  
Facsimile (202) 296-1682  
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